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APPLICANT: SHARP CORP;

INVENTOR:

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INT.CL.

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TITLE

: COATING METHOD FOR GRAPHITE SUBSTRATE WITH SILICON CARBIDE

ABSTRACT :

PURPOSE: To form a SiC coating layer of good adherence on a graphite substrate by forming a silicon layer on the surface of a porous carbon layer formed on the substrate after which the silicon layer is recrystabilized and carbonized with the carbon layer.

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